

<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	<b>Atty Docket No.</b>	ANDIP035/425565
	<b>Application No.:</b>	10/648,624
	<b>Applicant</b>	Hoffman et al.
	<b>Filing Date</b>	August 25, 2003
	<b>Group</b>	<del>2016</del> 2416
	<b>Confirmation No.</b>	5322
		Page 1 of 1

#### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	1.	5,920,568	07/06/99	Kurita et al.	.....	.....	01/29/97
	2.	2002/0075884	06/20/02	Wellen	.....	.....	12/12/01
	3.						
	4.						

#### Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
							Yes	No
	5.	EP1303079A2	04/16/03	EPO	.....	.....	X	
	6.	CN1359241A	07/17/02	CN	.....	.....		X
	7.	CN1099923A	03/08/95	CN	.....	.....		X
	8.	WO94/20904	09/15/94	WIPO	.....	.....	X	

#### Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	9.	Examiner Shu Wang, Chinese Office Action in corresponding application no. 200480020777.9 dated November 21, 2008. 14 pages.
	10.	
	11.	
	12.	
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	14.	
	15.	
	16.	

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.H./

<b>Examiner</b>	/Clemence Han/	<b>Date Considered</b>	03/27/2009
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.